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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Koji MATSUKUMA

Application No.: Rule 53(b) Divisional of  
Application No. 09/219,707

Filed: Docket No.: 102392.01

For: ETCHING MASK, METHOD OF MAKING SAME, ETCHING METHOD,  
MAGNETIC HEAD DEVICE AND METHOD OF MANUFACTURING SAME

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D. C. 20231

Sir:

~~Prior to initial examination, please amend the above-identified application as follows:~~

IN THE TITLE:

~~Please delete the original title and insert therefor the following new title: --ETCHING  
MASK AND MAGNETIC HEAD DEVICE--.~~

IN THE CLAIMS:

~~Please cancel claim 1 without prejudice to or disclaimer of the subject matter  
contained therein.~~

~~Please add new claims 27-37 as follows:~~

~~--27. An etching mask for selectively etching a workpiece, wherein the etching  
mask is made of a metal and has a cross-sectional shape comprising a rectangular first region  
that determines a pattern width of the workpiece, and a second region that intercepts  
application of etching beams to a sidewall of the first region during etching.--~~

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